

AF/1FW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Handwritten:
Please
Enban
4/10/2006

In re Application of:)
Chen et al.)
Serial No.: 10/697,589)
Filed: October 30, 2003)
For: METHOD FOR MAKING)
NANOSCALE WIRES AND)
GAPS FOR SWITCHES AND)
TRANSISTORS)

Examiner: WEISS, H.
Art Unit: 2814
Confirmation No.: 8317

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENTS AND REMARKS

Dear Sir:

In response to the Office Action mailed January 31, 2006, please consider the following remarks and enter the following amendments.

Amendments to the claims are presented beginning on page 2 of this response. Remarks begin on page 5 of this response.